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Transmission Date: July 18, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Schulze, *et al.*

Docket No.: 115747-0003//2002P50544US

Serial No: 10/753,604

Art Unit: 1756

Date Filed: January 8, 2004

Examiner: Stephen D. Rosasco

Title: Method For The Repair Of Defects In Photolithographic Masks For Patterning
Semiconductor Wafers

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Respectfully submitted,

Kristy Engeldahl
Legal Assistant

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Patterning Semiconductor Wafers

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's
Final Office Action mailed May 18, 2006. Please amend the above-referenced application as
follows.